



Attorney Docket-SEL 195

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
Yamazaki et al.)
Serial No.: 09/610,753)
Filed: July 6, 2000)
For: Semiconductor Device And)
Manufacturing Method Thereof)
Art Unit: 2815)
Examiner: P. Brock III)

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Rachelle Hammerquist
Name of applicant, assignee, or Registered Rep.

Rachelle Hammerquist 12-9-02
Signature Date

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And
Immediat
2/3/03

Commissioner for Patents
Washington, D.C. 20231

December 9, 2002

AMENDMENT C

Sir:

Please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend the claims as follows:

1. (Amended) A semiconductor device comprising:
- a pixel TFT disposed in a pixel section over a substrate; and
 - a driver circuit comprising a p-channel TFT and an n-channel TFT, over the substrate;
 - a first interlayer insulating film comprising an inorganic insulating material over a gate electrode of the pixel TFT;
 - a second interlayer insulating film comprising an organic insulating material over the first interlayer insulating film; and
 - a pixel electrode having a light reflective surface over the second interlayer insulating film, and electrically connected with the pixel TFT through an opening in the first and second interlayer

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